

BAR CODE LABEL



U.S. PATENT APPLICATION

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CONTINUING DATA***
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FOREIGN/PCT APPLICATIONS***

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TITLE

METHOD FOR PRODUCING SEMICONDUCTOR INTEGRATED CIRCUITS AND APPARATUS
 USED IN SUCH METHOD

This is to certify that annexed hereto is a true copy from the records of the United States Patent and Trademark Office of the application as filed which is identified above.

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Date

Certifying Officer